

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Akihiko ENDO et al.

**Confirmation No.: 1243**

Appl. No. : 10/570,668

Group Art Unit : 2891

Filed : March 6, 2006

Examiner : Bradley SMITH

For : SOI WAFER AND ITS MANUFACTURING METHOD

**AMENDMENT UNDER 37 C.F.R. 1.111**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop AMENDMENT  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir :

This is in response to the Official Action mailed from the U.S. Patent and Trademark Office on February 7, 2008, which sets a three-month shortened statutory period for response until May 7, 2008. Inasmuch as this paper is filed by or prior to the initial due date, no extension of time is required. If for any reason an extension is deemed necessary, Applicants hereby request any required extension of time to maintain the pendency of the application and authorize the charging of any fee necessary to maintain the pendency of the application, including any required extension of time fee and/or any required claim fee, to Deposit Account No. 19-0089.

Reconsideration and withdrawal of the rejections of record are respectfully requested in view of the following amendments and remarks.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 9 of this paper.